

1765

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): GEUN-YOUNG YEOM

Docket No.

HNE-0001

Serial No.
10/010,548Filing Date
AUG 01 2003
11/08/2001

Examiner

Group Art Unit

Invention: METHOD OF ETCHING SEMICONDUCTOR DEVICE USING NEUTRAL BEAM AND APPARATUS FOR
ETCHING THE SAME

RECEIVED

AUG 07 2003

TC 1700

I hereby certify that this Response to Restriction Requirement w/ Amendment/Pursuant to 37 CFR Section 1.111
(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 28, 2003

(Date)

Jennifer Matson

(Typed or Printed Name of Person Mailing Correspondence)

(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.